



Handwritten notes: 2815, 1-24-01, #4, and a signature.

P/1071-1118

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of
Makoto INAI, et al.
Serial No.: 09/658,732
Filed: September 11, 2000

New York, New York
Date: January 10, 2001
Group Art Unit: ----
Examiner: ----

For: **FIELD-EFFECT SEMICONDUCTOR DEVICE**

Assistant Commissioner for Patents
Washington, D.C. 20231

RECEIVED
JAN 19 2001
TECHNOLOGY CENTER 2800

INFORMATION DISCLOSURE STATEMENT

Sir:

Submitted herewith is a copy of art together with a form listing the same
for the convenience of the Examiner.

I hereby certify that this correspondence is being
deposited with the United States Postal Service with
sufficient postage as first class mail in an envelope
addressed to: Assistant Commissioner for Patents,
Washington, D.C. 20231, on January 10, 2001

Martin Pfeffer

Name of applicant, assignee or
Registered Representative

Signature

Date of Signature

Respectfully submitted,

Martin Pfeffer

Registration No.: 20,808

OSTROLENK, FABER, GERB & SOFFEN, LLP

1180 Avenue of the Americas

New York, New York 10036-8403

Telephone: (212) 382-0700

MP:jj
Enclosures